



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 14, 2026

IGI Report Number

LG826689160

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT

Measurements

12.82 X 8.99 X 5.98 MM

GRADING RESULTS

Carat Weight

6.05 CARATS

Color Grade

E

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

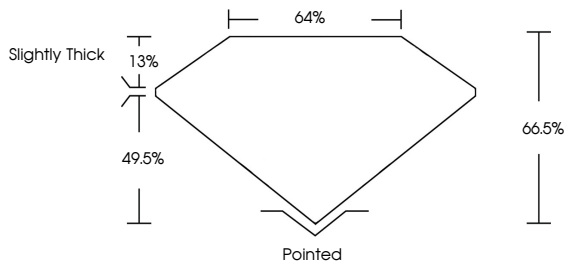
Inscription(s)

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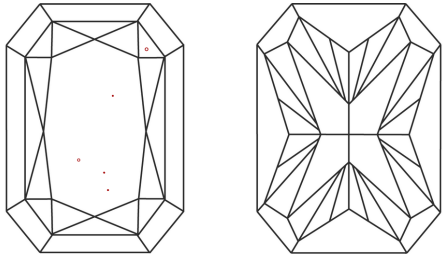
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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12.82 X 8.99 X 5.98 MM

Carat Weight

6.05 CARATS

Color Grade

E

Clarity Grade

VS 1

Table

13%

Depth

49.5%

Girdle

Slightly Thick

Culet

Pointed

Polish

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Fluorescence

NONE

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